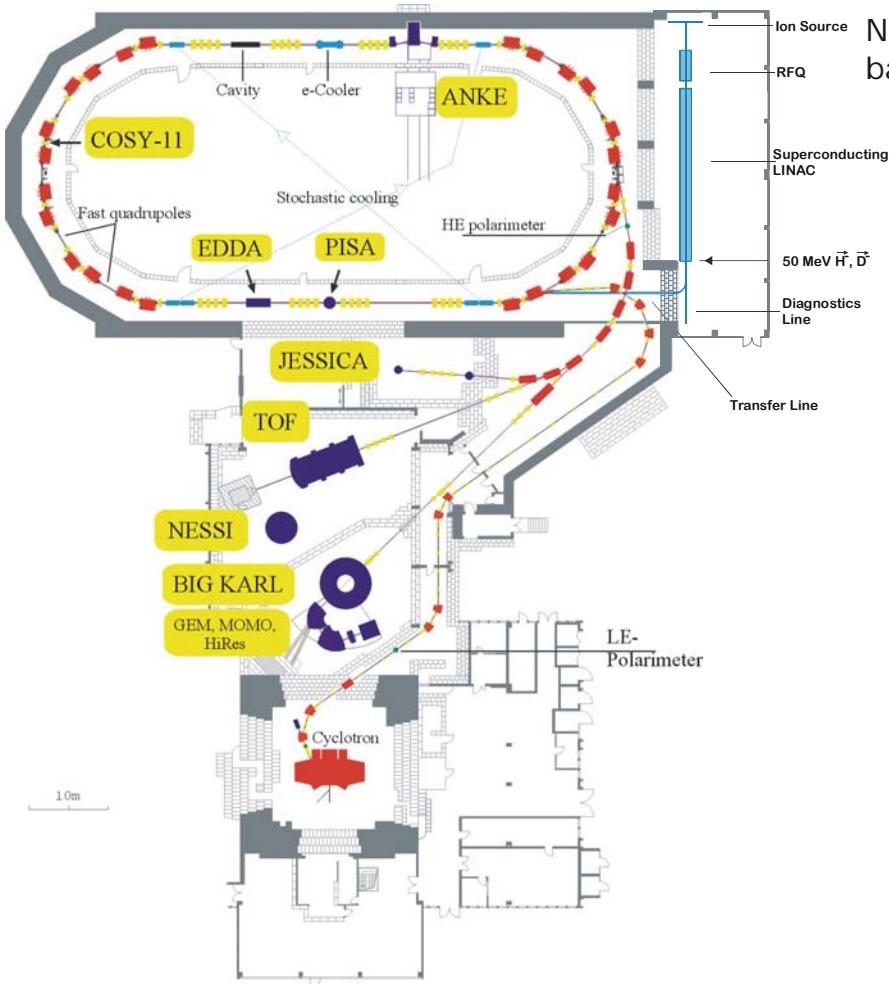


# The HW resonators in Juelich

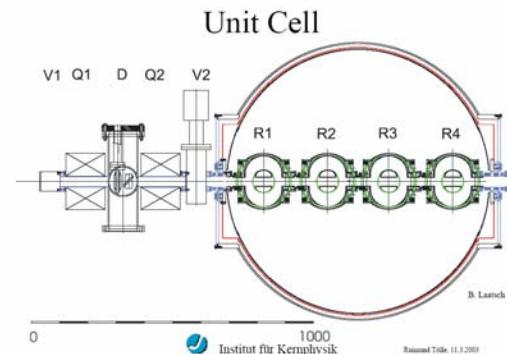
- *The Halfwave-Resonator*
  - *RF Main-coupler*
  - *Tuner*
- *RF-Measurements*
  - *Cw operation*
  - *Pulsed mode: mechanical resonances, LFD, I/Q-control*
- *Outlook*



# Accelerating facility COSY: new injector



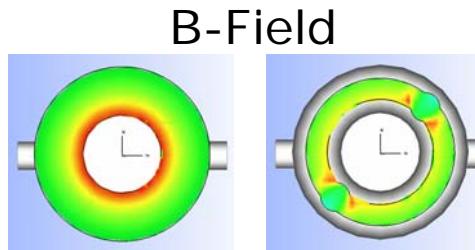
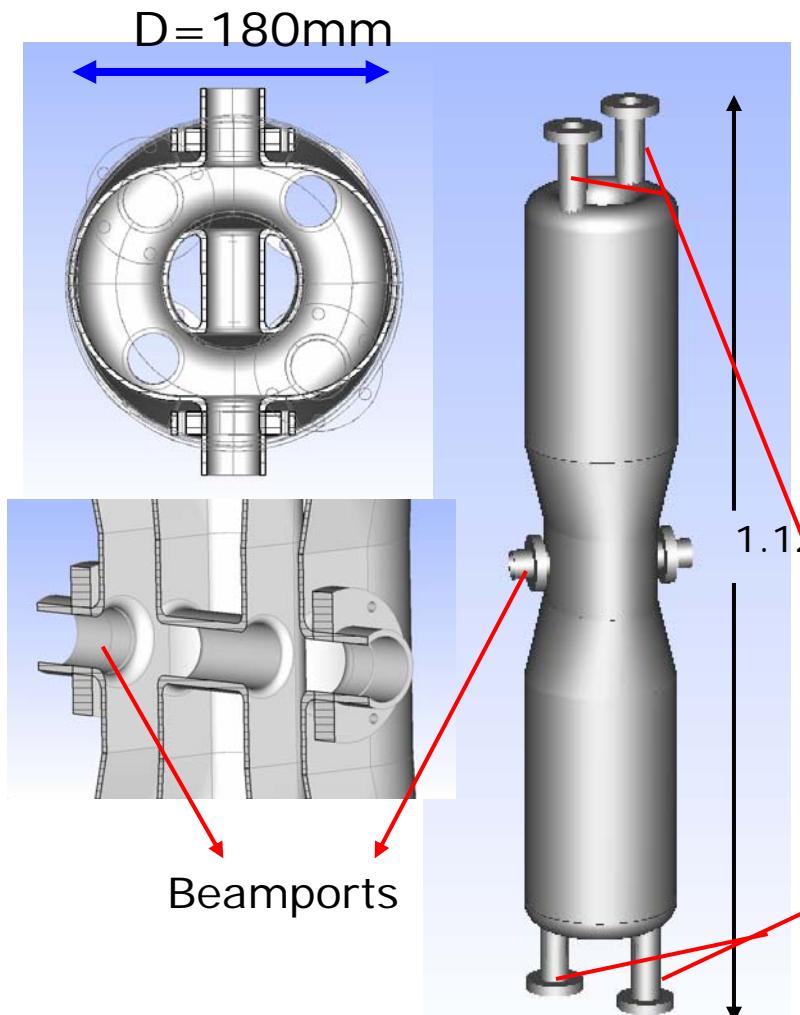
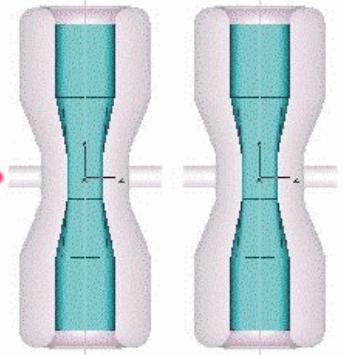
New injector  
based on SC-HWR



- pulsed operation (2 Hz, 500  $\mu$ s beam)
- beam-current = 2mA
- Injection-energy = 2.5 MeV/u
- 20 resonators 160 MHz,  $\beta = 0.11$
- 24 resonators 320 MHz,  $\beta = 0.2$
- 4 resonators (same type) each cryostat @4K
- final-energy 52 MeV (H-) / 56 MeV (D-)
- $E_{acc} = 8 \text{ MV/m}$  ( $B_{peak} = 80 \text{ mT}$ ,  $E_{peak} = 38 \text{ MV/m}$ )
- Focusing quadrupoles and diagnostic outside the cryostats



# HWR Parameter (160MHz, $\beta=0.11$ )



$$E_{acc} = \frac{\int_{-\infty}^{\infty} E_z(z, t(z)) dz}{\beta_{str} \lambda}$$

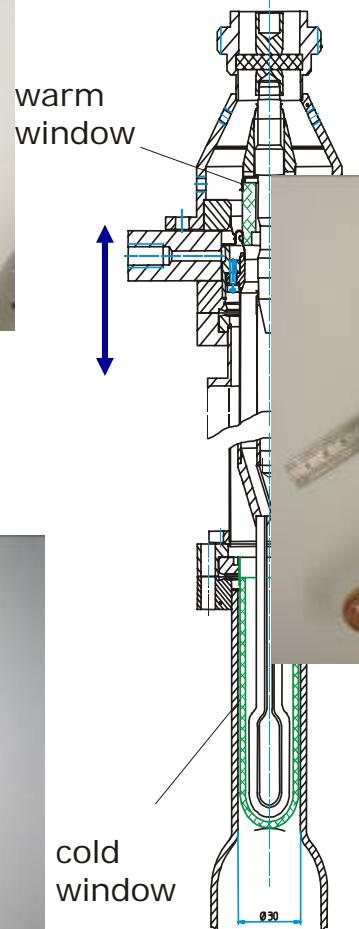
R/Q / $\Omega$	245
G / $\Omega$	26
B <sub>peak</sub> /E <sub>acc</sub> / mT/MV/m	10.4
E <sub>peak</sub> /E <sub>acc</sub>	4.8

4 Accessports (chemical preparation, HPR)  
Used for couplers and additional pumping

# RF main coupler



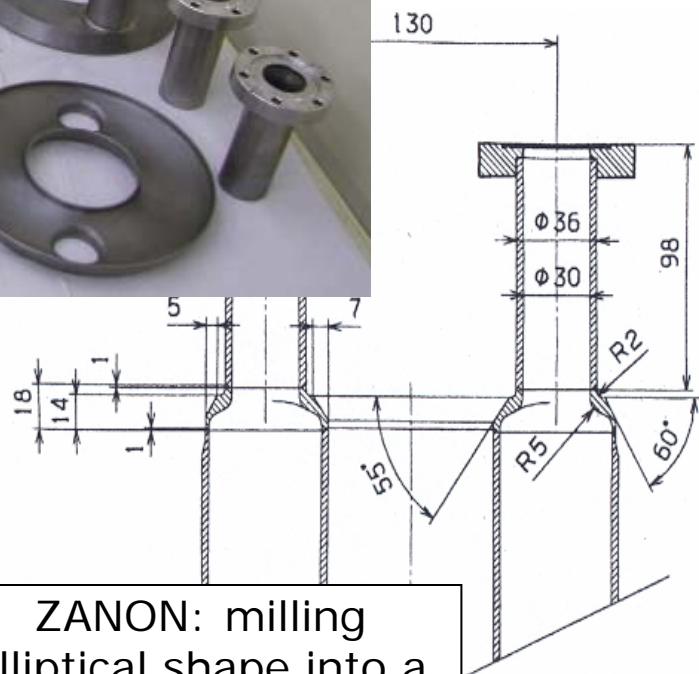
- Inductive coupling from the tank
- 4 kW Peak Power at 100% Reflected Power
- 150 W average power
- adjustable:  
 $10^6 < Q_{\text{ext}} < 10^9$
- 2 RF windows (warm/cold)
- $< 5 \text{ mW}$  cold window leak rate
- cold window layer



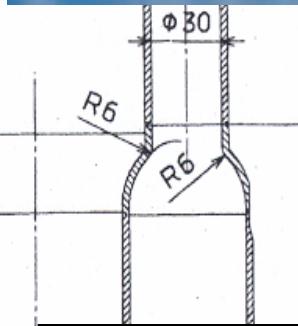
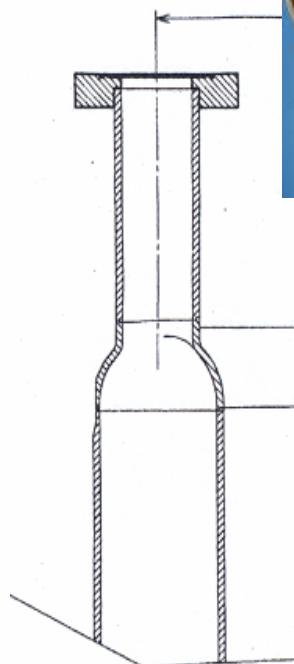
# Two different prototypes from two manufactures



1. difference:  
Fabrication of  
endplates

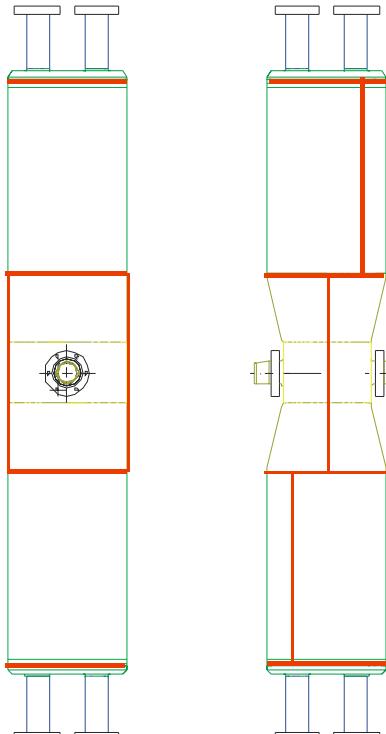


ZANON: milling  
elliptical shape into a  
20mm Niobium-Plate

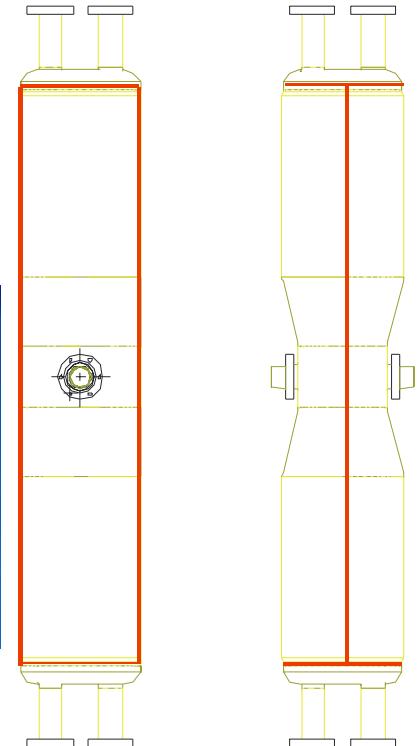
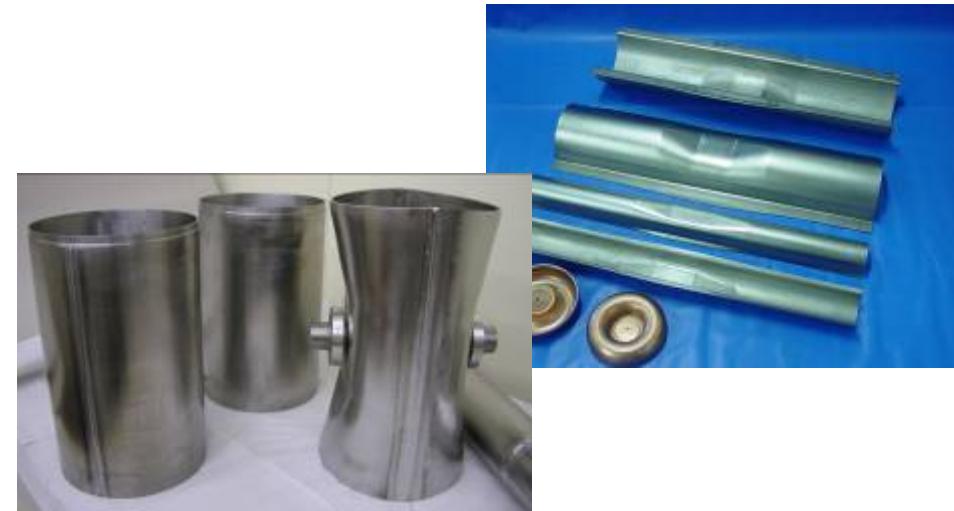


ACCEL: preferred  
circular shape by  
spinning

## Two different prototypes from two manufactures (2)



2. difference:  
quantity and  
position of weldings



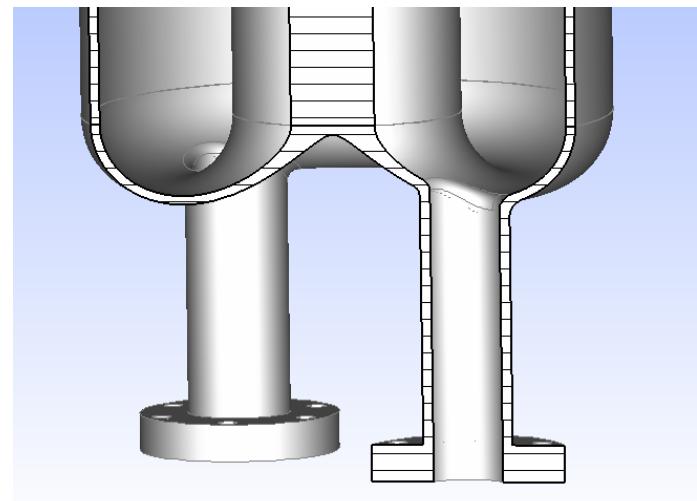
ZANON:  
Eight pieces + endplates

ACCEL:  
Four halfcells + endplates

# Preparation for both cavities done by ACCEL



- Ultrasonic cleaning
- 120µm BCP in closed pumped system (temperature controlled), cleaning and filling with pure water
- High pressure rinsing via access-ports (30min each port)
- Drying by pumping in clean-room
- No heat treatment
- No baking

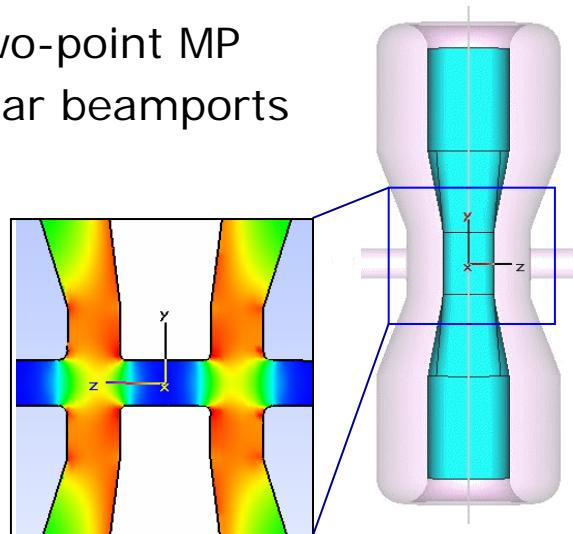


# 4K-Measurement: Multipacting



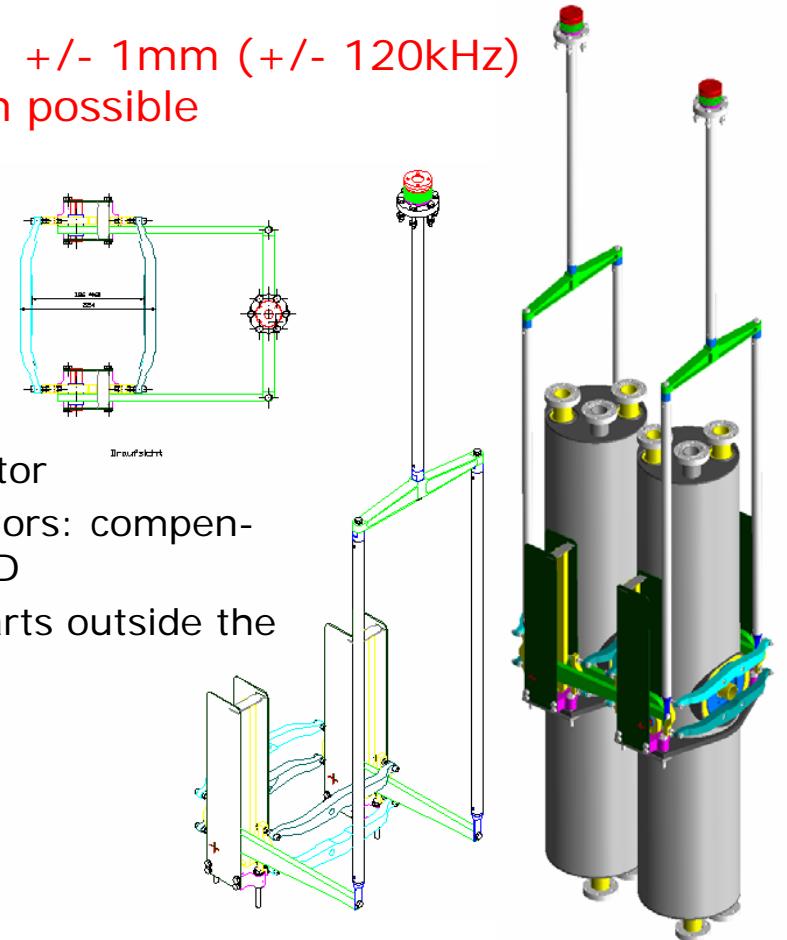
- First Multipacting barrier at some mW ( $E_{acc} \sim \text{keV}$ )
- Conditioning with 5W RF-Power for about 3 weeks

Two-point MP  
near beamports

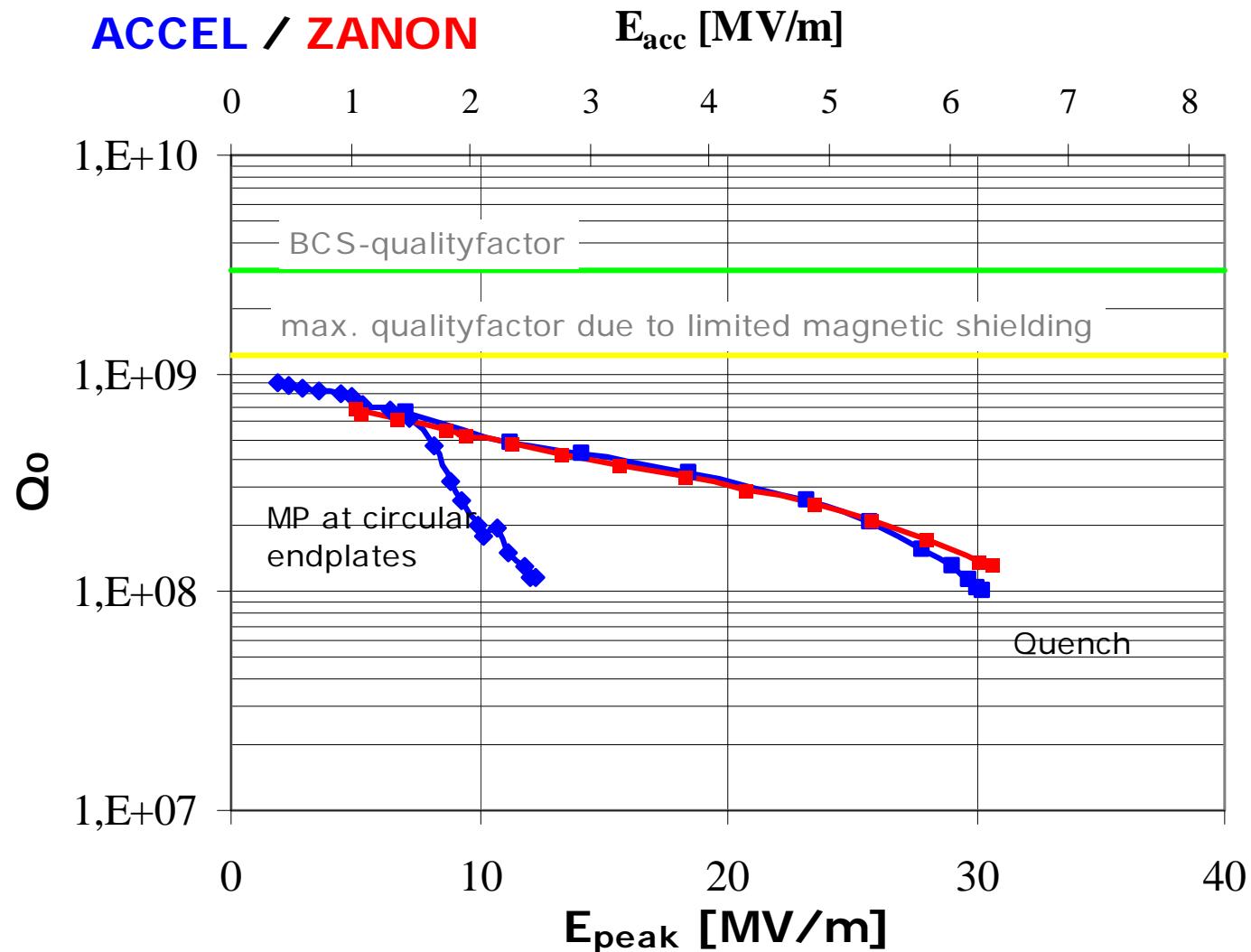


Tuningrange: +/- 1mm (+/- 120kHz)  
Initial tension possible

- Stepper motor
- Piezo actuators: compensation of LFD
- All active parts outside the cryostat



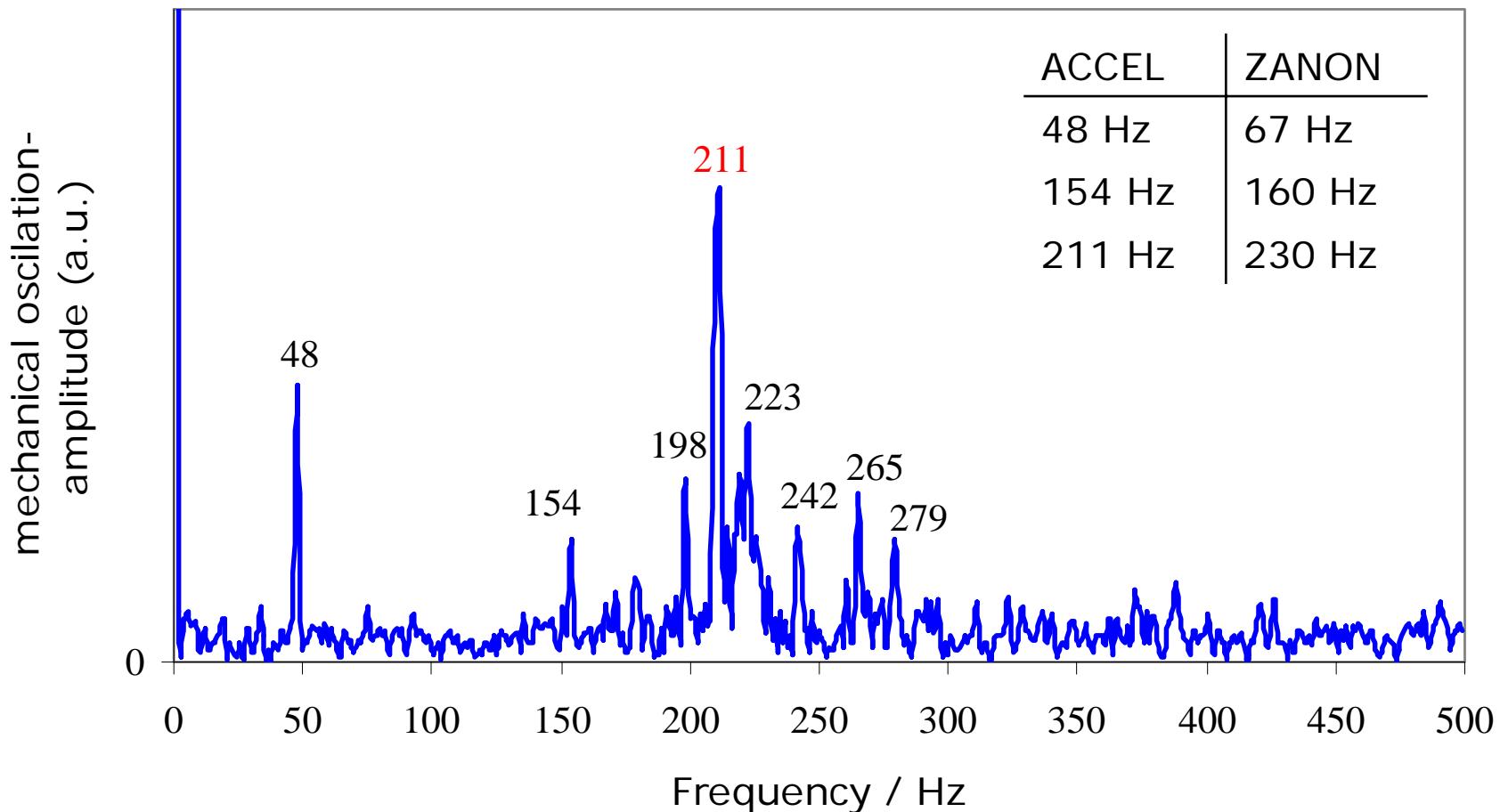
For details see Poster TuP32: R.Eichhorn



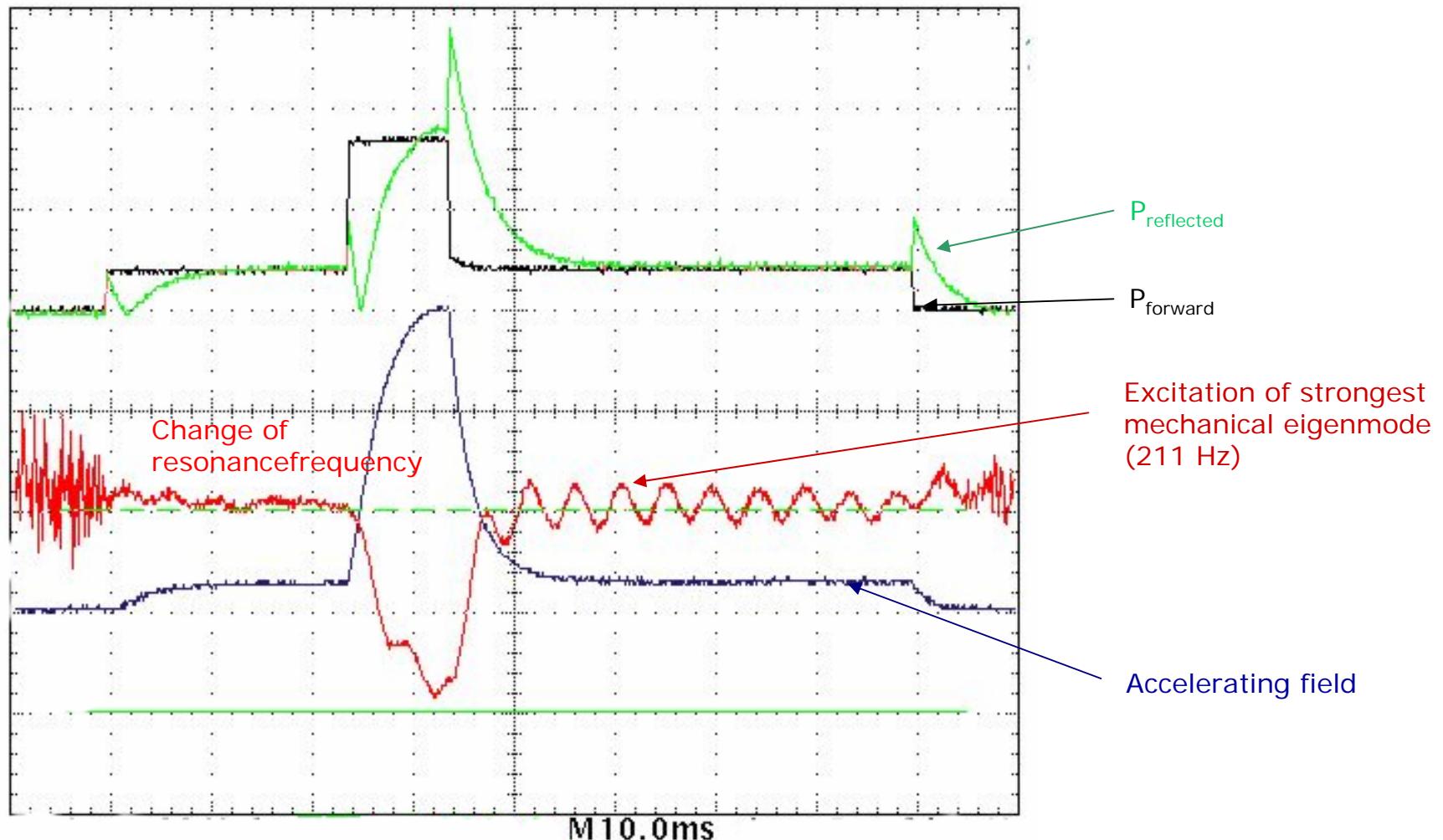
# Mechanical Eigenmodes



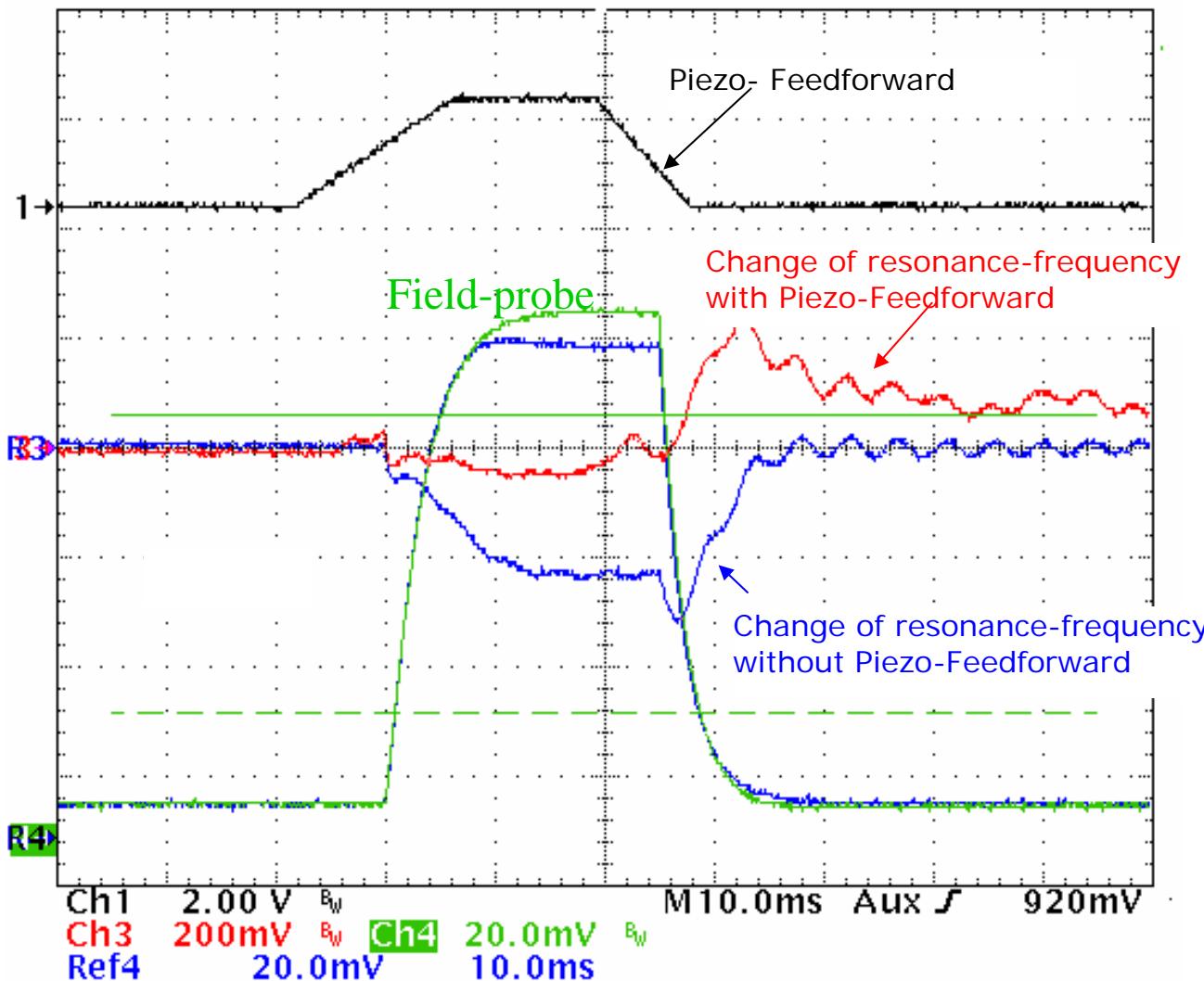
- 1) FFT of phase-signal after step-function at Piezo-Tuner
- 2) Sinusoidal excitation



# Mechanical resonances in pulsed operation



# Lorentz-Force-Detuning



Static detuning:

$$\Delta f = -\mathbf{k} * E_{acc}^2$$

ZANON: 6 Hz/(MV/m)<sup>2</sup>  
ACCEL : 10 Hz/(MV/m)<sup>2</sup>

First ANSYS®-Simula-  
tion: 1 Hz/(MV/m)<sup>2</sup>

$$E_{acc} = 3,1 \text{ MV/m}$$

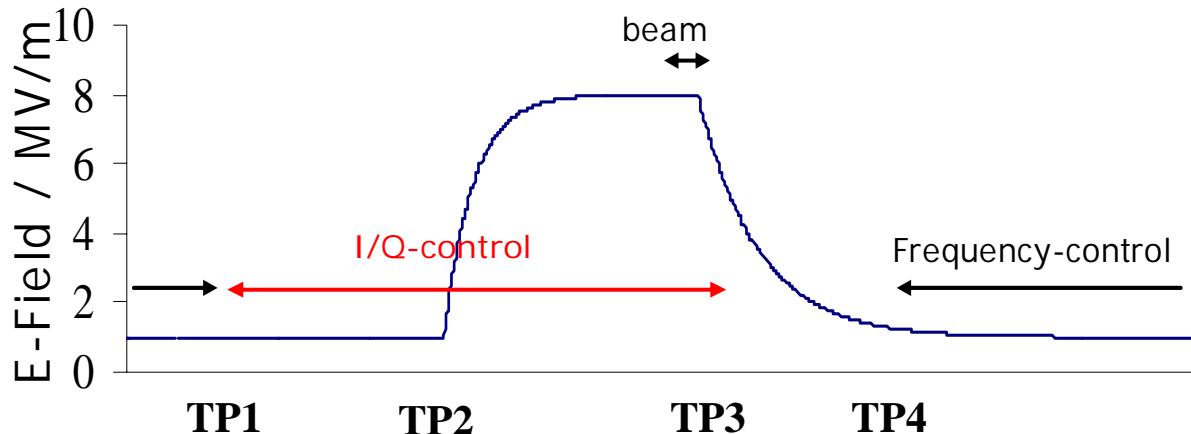
$$\Rightarrow LFD = 60 \text{ Hz}$$

Pulse-length: 25ms

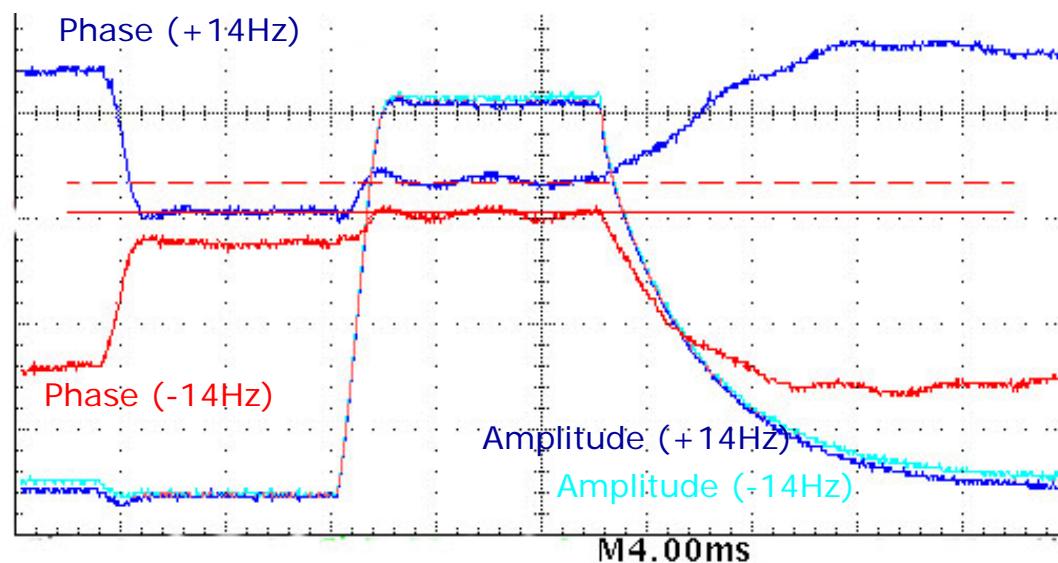
Limited by mechanical  
inertia



# Analogue I/Q-control



- TP1:** Activating the I/Q-control,  
frequency-control switched off
- TP2:** Triggering the highfield-puls
- TP3:** I/Q-control and pulsing switched off
- TP4:** Activating the frequency-control loop



Field accuracy:

**Achieved  
(worst case)**

**Goal**

+/- 0,6% Amplitude (+/- 0,5%)  
+/- 1,4° Phase (+/- 0,5° )



# Conclusion and next steps



- 8 MV/m possible but up to now not serious in a 7000 h/a linac operation
- Mechanical stability requires modifications
- RF-conditioning, baking, (He-processing)
- 2K-operation
- Installation of one prototype including LHe-cover in the new cryostat

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MAC members:

B. Aune, A. Facco, D. Proch, U. Ratzinger,  
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